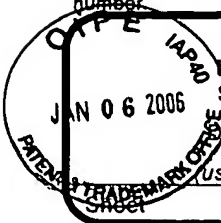


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	INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Application Number	10/815,517
	Date Submitted: January 6, 2006		Filing Date	4/1/2004
	(use as many sheets as necessary)		First Named Inventor	Hongxing Tang
	1 of 1		Group Art Unit	2856
			Examiner Name	Rose Mary MILLER
			Attorney Docket Number	049411-0266

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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NON PATENT LITERATURE DOCUMENTS				
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RM	A1	BARGATIN et al., "Sensitive detection of nanomechanical motion using piezoresistive signal downmixing," Applied Physics Letters, 86, 133109-1 - 133109-3, 2005.		
RM	A2	JUDY et al., "Magnetic Microactuation of Polysilicon Flexure Structures," IEEE Journal of Microelectromechanical Systems, Vol. 4, No. 4, December 1995, pp. 162-169,		
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Examiner Signature	/Rose Miller/	Date Considered	07/07/2006
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